

U.S. Department of Commerce, Patent and Trademark Office		Sheet 1 of 1
		Atty. Docket No.: ZEB0020D2US
		Application No.: 10/014,681
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Inventor(s): Michael A. Klug, et al.
Adapted from USPTO Form 1449		Filing Date: December 11, 2001
		Group Art Unit: 2872

U.S. Patents and U.S. Published Patent Applications

*Examiner Initial		Document Number	Date	Inventor		
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation (Y/N)
/ACL/	D02	JP 1102492	4/20/89	Japan	G03H	1/26	Abstract
/ACL/	D03	WO 92/01976	2/6/92	PCT	G03H	1/30	
/ACL/	D04	JP 5181404	7/23/93	Japan	G03H	1/26	Abstract
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/ACL/	D11	Lanteigne, D. J., "Single laser exposure and monitoring of holograms," US Statutory Invention Registration No. H841, Nov. 6, 1990, 4 pages.
/ACL/	D12	International Search Report, 10/27/99 for Application No. PCT/US99/14006.
/ACL/	D13	Communication of May 26, 2009 from Japanese Patent Office for Application No. 2000-582854, English translation, pp. 1-7.
/ACL/	D14	Communication of March 2, 2010 from Japanese Patent Office for Application No. 2000-582854, English translation, pp. 1-3.

Examiner signature: /Arnel C. Lavarrias/

Date Considered: 07/27/2010

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.